

1/3

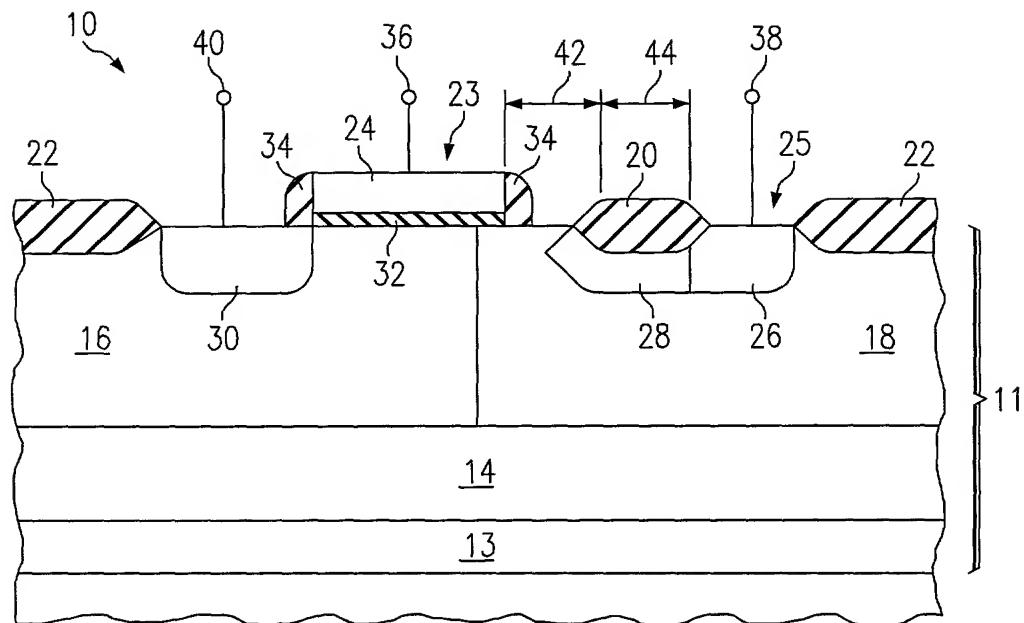


FIG. 1

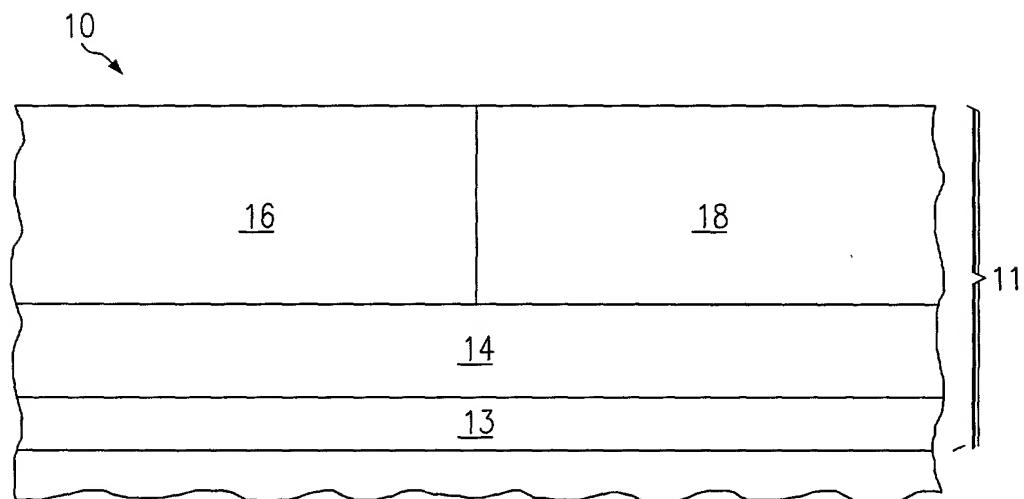


FIG. 2

Method of Manufacturing and Structure of
Semiconductor Device with Field Oxide
Structure

Attorney Docket: 032350.B373

Inventor: Xiaoju (nmi) Wu

Filed: 12/07/2001 Sheets: 2 of 3

2/3

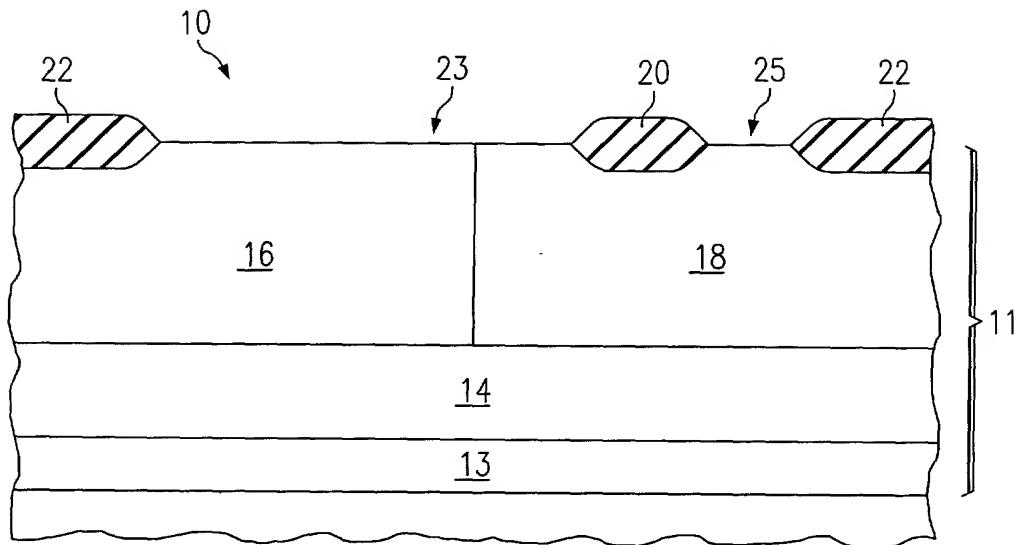


FIG. 3

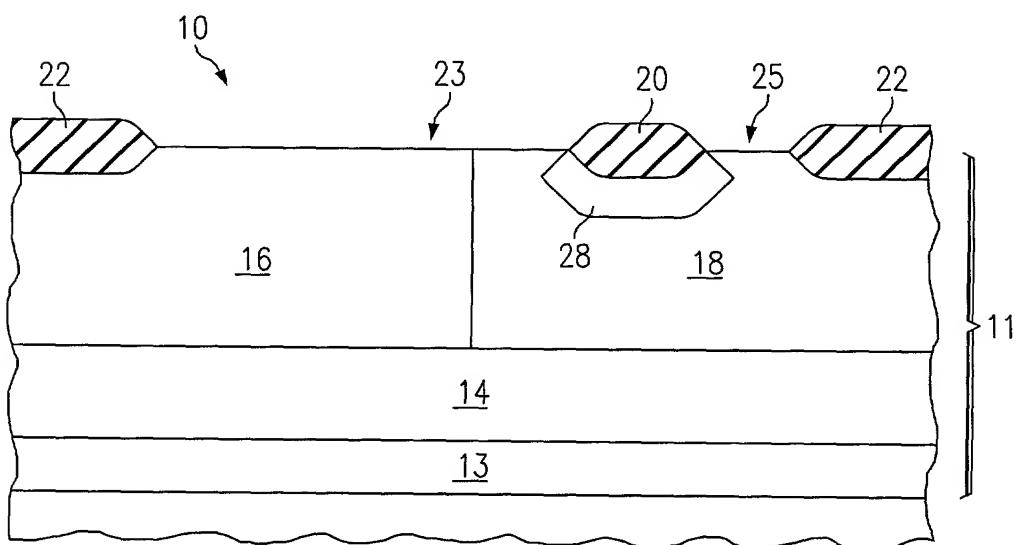


FIG. 4

Method of Manufacturing and Structure of
Semiconductor Device with Field Oxide
Structure

Attorney Docket: 032350.B373

Inventor: Xiaoju (nmi) Wu

Filed: 12/07/2001 Sheets: 3 of 3

3/3

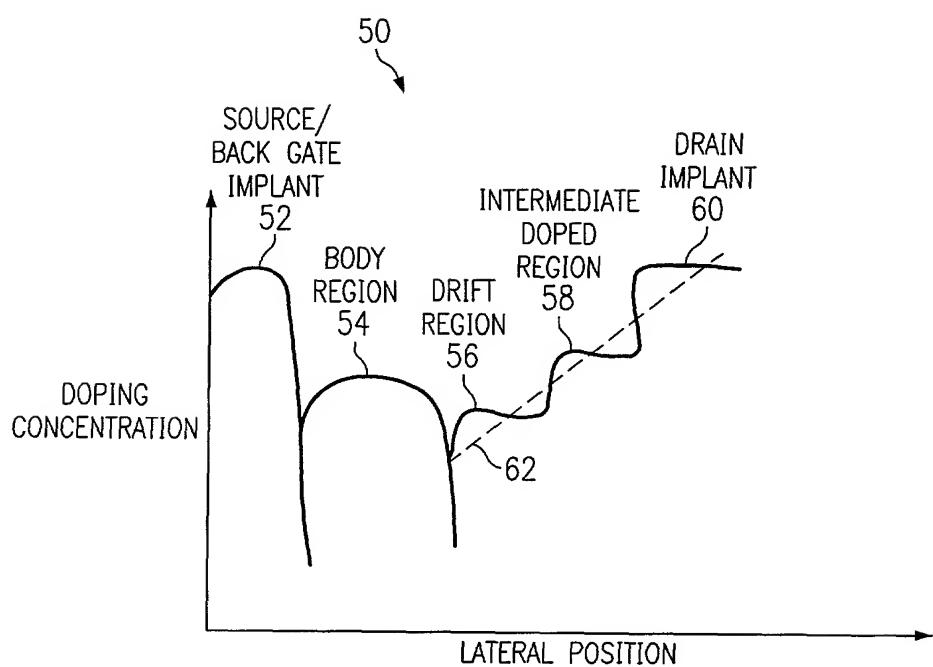


FIG. 5